

03500.016650.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: T.V. Tran
SHUJI AOKI ET AL.)	
	:	Group Art Unit: 2821
Application No.: Division)	
of U.S. Patent Appln.	:	
No. 10/227,346)	
	:	
Filed: Herewith)	
	:	
For: METHOD AND APPARATUS FOR)	
ADJUSTING CHARACTERISTICS	:	
OF MULTI ELECTRON SOURCE)	August 26, 2003

Mail Stop
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT
AND
INFORMATION DISCLOSURE STATEMENT

Sir:

Preliminary to examination, please amend the above-identified application,
filed herewith, as follows: